Uncertainty Analysis of Reaction Rates in a Finite-Rate Gas-Surface Model

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AFOSR MURI Fundamental Processes in High Temp. Gas-Surface Interactions



Acknowledgments

- Dr. Ioana Cozmuta (Co-PI on catalysis work)
- Prof. Adri van Duin
- University of Minnesota researchers:
 - Dr. Paolo Valentini
 - Paul Norman
 - Cory Sorensen
 - Savio Poovathingal



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1) Finite-Rate Catalytic (FRC) wall boundary condition implemented in US3D CFD code. Uncertainty analysis performed.

2) Computational Chemistry simulations and the development of a FRC model for oxygen-silica catalysis under hypersonic conditions.

3) Preliminary results for oxidation of carbon-based surface ablators.

Finite-Rate Catalytic (FRC) Boundary Condition

- Finite-rate chemistry in the gas-phase *and* at the wall
- Modifies diffusion/chemistry in the boundary layer (coupled problem)
 Ex. 2.7 km/s CO₂ flow (T_w=500 K)





Example: Air-silica catalysis model⁵

- (1) $O + [s] \rightarrow O_s$ Adsorpt (2) $N + [s] \rightarrow N_s$ Adsorpt (3) $O + O_s \rightarrow O_2 + [s]$ E - R R(4) $N + N_s \rightarrow N_2 + [s]$ E - R R(5) $O + N_s \rightarrow NO + [s]$ E - R R(6) $N + O_s \rightarrow NO + [s]$ E - R R(7) $O_{s,m} + O_s \rightarrow O_2 + 2[s]$ L - H R(8) $N_{s,m} + N_s \rightarrow N_2 + 2[s]$ L - H R(9) $O_{s,m} + N_s \rightarrow NO + 2[s]$ L - H R(10) $N_{s,m} + O_s \rightarrow NO + 2[s]$ L - H R(11) $O_s \rightarrow O + [s]$ Desorpt (12) $N_s \rightarrow N + [s]$ Desorpt
 - Adsorption Reaction Adsorption Reaction E - R Reaction E - R Reaction E - R Reaction E - R Reaction L - H Reaction L - H Reaction L - H Reaction L - H Reaction Desorption Reaction Desorption Reaction



(1)	$O + [s] \rightarrow O_s$	Adsorption Reaction
(2)	$N + [s] \rightarrow N_s$	Adsorption Reaction
(3)	$O + O_s \rightarrow O_2 + [s]$	$E - R \operatorname{Re} action$
(4)	$N + N_s \rightarrow N_2 + [s]$	E - R Reaction
(5)	$O + N_s \rightarrow NO + [s]$	$E - R \operatorname{Re}action$
(6)	$N + O_s \rightarrow NO + [s]$	$E - R \operatorname{Re}action$
(7)	$O_{s,m} + O_s \rightarrow O_2 + 2[s]$	L - H Reaction
(8)	$N_{s,m} + N_s \rightarrow N_2 + 2[s]$	$L - H \operatorname{Re} action$
(9)	$O_{s,m} + N_s \rightarrow NO + 2[s]$	L - H Reaction
(10)	$N_{s,m} + O_s \rightarrow NO + 2[s]$	L - H Reaction
(11)	$O_s \rightarrow O + [s]$	Desorption Reaction
(12)	$N_s \rightarrow N + [s]$	Desorption Reaction

¹ Halpern and Rosner, *Journal of the Chemical Society*, 1978

² Deutschmann, O., Riedel, U., and Warnatz, J., J. Thermophys. Heat transfer, 1995

³ Thomel, J., Lukkien, J. J., and Chazot, O., AIAA Paper 2007-4399, June 2007

⁴ Valentini, Schwartzentruber, and Cozmuta, AIAA Paper 2009-3935, June 2009

⁵ Marschall, MacLean, and Barnhardt, "A Finite Rate Surface Reaction Model for DPLR", NASA 2011

Finite-Rate Model and Parameters



Example: Air-silica catalysis model⁵

- $(1) \quad O+[s] \to O_s$
- $(2) \quad N+[s] \to N_s$
- (3) $O + O_s \rightarrow O_2 + [s]$
- (4) $N + N_s \rightarrow N_2 + [s]$
- (5) $O + N_s \rightarrow NO + [s]$
- (6) $N + O_s \rightarrow NO + [s]$
- (7) $O_{s,m} + O_s \rightarrow O_2 + 2[s]$
- $(8) \quad N_{s,m} + N_s \rightarrow N_2 + 2[s]$
- $(9) \quad O_{s,m} + N_s \to NO + 2[s]$
- (10) $N_{s,m} + O_s \rightarrow NO + 2[s]$
- $(11) \quad O_s \to O + [s]$
- (12) $N_s \rightarrow N + [s]$

- Adsorption Reaction Adsorption Reaction E - R Reaction
- E R Reaction
- E R Reaction
- E R Reaction
- L H Reaction
- $L H \operatorname{Re} action$
- L H Reaction
- L H Reaction

Desorption Reaction

Desorption Reaction

 $k_f = \left(\frac{\bar{v}}{4\Phi_{total}}\right) \gamma_o T^\beta \exp\left(-\frac{E_{er}}{RT}\right)$

Eley – Rideal

$$\gamma_{er,O} = \gamma_{er,N} = 0.001$$

 $\beta_O = \beta_N = 0$
 $E_{er,O} = E_{er,N} = 9000 J/mol$
(Φ_{total}) is set to 7.5x10⁻⁶ mol/m²



Elementary atomistic quantities

- ² Deutschmann, O., Riedel, U., and Warnatz, J., J. Thermophys. Heat transfer, 1995
- ³ Thomel, J., Lukkien, J. J., and Chazot, O., AIAA Paper 2007-4399, June 2007

¹ Halpern and Rosner, Journal of the Chemical Society, 1978

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Excellent agreement despite completely different implementation procedures
 Ex. 6 km/s air flow over 1m radius cylinder (T_w=2250 K)



MacLean, Marschall, and Driver, **AIAA Paper 2011-3784**, Honolulu, HI. Sorensen, Valentini, and Schwartzentruber, **AIAA Paper 2011-3643**, Honolulu, HI. Sorensen, Valentini, and Schwartzentruber, **J. Thermophysics and Heat Transfer**, In-press. 5th Ablation Workshop (2/29/12) • Natural result of FRC model is that $\gamma = f$ (surface coverage) ~ f (pressure) - γ increases by 4x between $\theta = 0^{\circ}$ and $\theta = 90^{\circ}$ despite constant T_{wall}



MacLean, Marschall, and Driver, AIAA Paper 2011-3784, Honolulu, HI.
Sorensen, Valentini, and Schwartzentruber, AIAA Paper 2011-3643, Honolulu, HI.
Sorensen, Valentini, and Schwartzentruber, J. Thermophysics and Heat Transfer, In-press. 5th Ablation Workshop (2/29/12) Specifying Consistent Backwards Rates



Certain backwards rates must be set consistent with the *gas-phase* thermodynamics:

Park 90 model for air:

 $N_2 \stackrel{k_{eq}^{d1}}{\longleftarrow} N + N , \qquad k_{eq}^{d1} = \frac{[N]^2}{[N_2]}$ $O_2 \stackrel{k_{eq}^{d2}}{\longleftarrow} O + O , \qquad k_{eq}^{d2} = \frac{[O]^2}{[O_2]}$

$$NO \stackrel{k_{eq}^{d3}}{\longleftrightarrow} N + O , \qquad k_{eq}^{d3}$$

$$NO + O \xleftarrow{k_{eq}^{ex1}} N + O_2 , \quad k_{eq}^{ex1} = \frac{k_{eq}^{d3}}{k_{eq}^{d2}}$$

$$NO + N \stackrel{k_{eq}^{ex2}}{\longleftrightarrow} O + N_2 , \quad k_{eq}^{ex2} = \frac{k_{eq}^{d3}}{k_{eq}^{d1}}$$

$$O + (s) \qquad \underbrace{\frac{k_f^1}{k_b^1}}_{k_b^1} \qquad O(s)$$
$$O + O(s) \qquad \underbrace{\frac{k_f^3}{k_b^3}}_{k_b^3} \qquad O_2 + (s)$$

$$\begin{aligned} k_{eq}^1 &= \frac{k_f^1}{k_b^1} = \frac{[O(s)]}{[O][s]} \\ k_{eq}^3 &= \frac{k_f^3}{k_b^3} = \frac{[O_2][s]}{[O][O(s)]} \end{aligned}$$

$$k_b^3 = k_f^3 k_{eq}^1 k_{eq}^{d2}$$

5th Ablation Workshop (2/29/12)

[N][O]

Uncertainty Analysis (applied to rates)

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- Off-nominal rate sets determined by sampling each rate from a log-normal distribution centered at nominal value (~1 order of magnitude variation)
- 2000 US3D simulations (different rate sets) per wall temperature
- Chemical heat flux variation directly proportional to rate uncertainty (no unexpected non-linear coupling)



Rate Correlations





T_w=1750K

T_w=2750K



• Linear regression is used to determine the reactions' correlation to chemical heat flux

• E-R recombination is highly correlated to the heat flux at 1750K while reaction L-H oxygen shows no trend

• Adsorption of oxygen and L-H oxygen are both correlated to the heat flux at 2750K





- E-R is most correlated to heat flux at temperatures below 2000K
- Above 2000K, L-H becomes most correlated
- Around 2750K, adsorption of oxygen becomes most correlated
- All reactions which are most correlated involve oxygen only

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Conductive, Chemical, and Total Heat Flux





• Total heat flux is the sum of trans-rot and vibrational conductive terms plus chemical contribution

• An increase in chemical heat flux (due to rate uncertainty) does not lead to the same increase in total heat flux

• Due to an altered boundary layer state (more diatomic molecules), which lowers the conduction heat flux

- Note: We assume full energy accommodation



 $\Delta q_{conductive} = -(1 - \text{slope})\Delta q_{chem}$



- 1) Backwards surface reaction rates should be determined in a consistent manner with adsorption/desorption/gas-phase equilibrium constants.
- 2) $\gamma_0 = \text{fcn}(\text{Tw, and coverage})$, possibly parameterized by partial pressure of oxygen.
- 3) Uncertainty in chemical heat flux is directly linked to the dominant mechanism at that wall temperature and its associated uncertainty.
- 4) Uncertainty in chemical heat flux decreases (for same rate variation) as wall temperature increases due to diffusion-limited chemistry.
- 5) An increase in chemical heat flux due to rate uncertainty leads to only a fraction of that increase in total heat flux (reactivity alters the boundary layer and therefore the conductive heat flux).

In general, uncertainty in heat flux is 'well-behaved' for a given set of mechanisms. The problem lies in omitting mechanisms and/or applying in diffusion limited situations (heat flux insensitive to rates).



• Silica is a significant component in both ablative and non-ablative thermal protection systems because of its good insulating properties.

• Many TPS materials, including Space Shuttle Tiles, SiC, and Ultra High Temperature Ceramics (UHTCs) form layers of primarily SiO_2 (stoichiometric) when exposed to atomic oxygen[1-3].

• There is little experimental evidence as to the structure of a silica surface exposed to high T due to the difficulties of *in situ* measurements.

Goals: 1) What are the in-situ surface structures for silica surfaces?
2) What are the dominant catalytic mechanisms for dissociated oxygen interacting with such surfaces? (for example, we observe no high-T LH reactions...)
3) What are the associated rates?

[1] E. Jumper and W. Seward. *Journal of Thermophysics and Heat Transfer*, 1994
[2] M. Balat-Pichelin et al., *Chemical Physics*, 2003
[3] D. Alfano et al., *Journal of European Ceramic Society*, 2010

Prior Oxygen-Silica Research



(b) Oxygen Terminated (001) β -Cristobalite Surface (side). Topmost layer of oxygen highlighted in blue. • Assume that oxide layers formed on SiC are β -Cristobalite (SiO₂ polymorph)

• Furthermore, cleave this bulk material to form a surface and place adsorbed atoms arbitrarily on surface





• Assume that oxide layers formed on SiC are β -Cristobalite (SiO₂ polymorph)

• Furthermore, cleave this bulk material to form a surface and place adsorbed atoms arbitrarily on surface

• Such surfaces are highly unphysical (high energy dangling bonds)

• Stable (**non-catalytic**) reconstructions observed in our MD simulations and experimentally

Surface Coverage on High-T Amorphous SiO₂





Figure 14 – Visualization of annealed amorphous SiO2 after exposure to dissociated oxygen at high pressure. Defects are highlighted. Blue = (\equiv Si - O·). Green = (\equiv Si - O₂).

• There is experimental and computational evidence for the existence of the =Si-O defect [1-3], and the stable/non-catalytic (Si-O-Si) reconstructions [4]

[1] D. Griscom and L. Friebel., *Physical Review B*, 1981
[2] E. O'Reilly et al., *Physical Review B*, 1983
[3] V. Bermudez et al., *Phyiscal Review B*, 1979
[4] O. Sneh and S. George, *Journal of Physical Chemistry*, 1995

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- Isolate each defect and compute average **activation energies** and **steric factors** for reactions due to gas-phase collisions
- $T_{wall} = T_{gas}$ (Maxwell-Boltzmann velocities at random angle)



(a) $\phi = 30$

(b) $\phi = 75$

Finite-Rate Model via Computational Chemistry



Rate	Rate Equation	Functional Form	Α	E_a (eV)
\mathbf{r}_1^f	$k_1^f[O][E_s]$	$(\overline{c}_O/4) \times (2\pi r_s^2) \times (A_1^f e^{-E_1^f/(K_B T)})$	1.0	0.0
\mathbf{r}_1^r	$\mathbf{k}_1^r[\mathbf{O}_s]$	$\mathbf{A}_1^r\mathbf{e}^{-E_1^r/(K_BT)}$	10^{-15} (s ⁻¹)	4.25
r_2^f	$\mathbf{k}_{2}^{f}[\mathbf{O}][\mathbf{O}_{s}]$	$(\overline{c}_O/4) \times (2\pi r_s^2) \times (A_2^f e^{-E_2^f/(K_BT)})$	0.169	0.401
\mathbf{r}_2^r	$\mathbf{k}_{2}^{r}[\mathbf{O}_{2}][\mathbf{E}_{s}]$	$(\overline{c}_{O_2}/4) \times (2\pi r_s^2) \times (A_2^r e^{-E_2^r/(K_B T)})$	0.663	1.27
r_3^f	$\mathbf{k}_3^f[\mathbf{O}][\mathbf{O}_s]$	$(\overline{c}_O/4) \times (2\pi r_s^2) \times (A_3^f e^{-E_3^f/(K_BT)})$	1.13	0.253
\mathbf{r}_3^r	$\mathbf{k}_{3}^{r}[\mathbf{O}_{2s}]$	$\mathbf{A}_3^r \mathbf{e}^{-E_3^r/(K_BT)}$	10^{-15} (s ⁻¹)	4.14
r_4^f	$\mathbf{k}_{4}^{f}[\mathbf{O}][\mathbf{O}_{2s}]$	$(\overline{c}_O/4) \times (2\pi r_s^2) \times (A_4^f e^{-E_4^f/(K_BT)})$	0.172	0.303
\mathbf{r}_4^r	$\mathbf{k}_{4}^{r}[\mathbf{O}_{2}][\mathbf{O}_{s}]$	$(\bar{c}_{O_2}/4) \times (2\pi r_s^2) \times (A_4^r e^{-E_4^f/(K_B T)})$	0.716	1.18
r_5^f	$\mathbf{k}_{5}^{f}[\mathbf{O}_{2s}]$	$\mathbf{A}_5^f \mathbf{e}^{-E_5^f/(K_BT)}$	$1.20 imes 10^{14} ({ m s}^{-1})$	2.71
\mathbf{r}_5^r	$\mathbf{k}_{5}^{r}[\mathbf{O}_{2}][\mathbf{E}_{s}]$	$(\overline{c}_{O_2}/4) \times (2\pi r_s^2) \times (A_5^r e^{-E_5^r/(K_B T)})$	1.0	0.0
r_6^f	$\mathbf{k}_{6}^{f}[\mathbf{O}][\mathbf{E}_{f}]$	$(\overline{c}_O/4) \times (2\pi r_s^2) \times (A_6^f e^{-E_6^f/(K_BT)})$	1.0	0.0
\mathbf{r}_6^r	$\mathbf{k}_{6}^{r}[\mathbf{E}_{f}]$	$(A_6^re^{-E_6^f/(K_BT)})$	$10^{15} (s^{-1})$	0.130
r_7^f	$\mathbf{k}_{7}^{f}[\mathbf{O}][\mathbf{O}_{f}][\mathbf{E}_{c}]$	$(2\pi r_s \Lambda_D) \times (\overline{c}_O/4) \times P_{rc} \times (A_7^f e^{-E_7^f/(K_B T)})$	1.0	0.0
r_8^f	$\mathbf{k}_8^f[\mathbf{O}][\mathbf{O}_f][\mathbf{O}_c]$	$(2\pi r_s \Lambda_D) \times (\overline{c}_O/4) \times P_{rc} \times (A_8^f e^{-E_8^f/(K_B T)})$	1.0	0.2

Finite-Rate Model vs. Experiment



- Exponential trend of $\gamma(T)$ in general agreement with experiment - a direct result of dominant defects/mechanisms/activation energies
- Magnitude of γ influenced by surface roughness (currently fit to experiment)



(a) High Temperature FRC Model

[A] Balat-Pichelin, M., Badie, J., Berjoan, R., and Boubert, P., "Recombination coefficient of atomic oxygen on ceramic materials under earth re-entry conditions by optical emission spectroscopy," Chemical Physics, Vol. 291, No. 2, 2003, pp. 181–194.

[B] Stewart, D. A., "Surface Catalysis and Characterization of Proposed Candidate TPS for Access-to-Space Vehicles," NASA Technical Memorandum 112206, 1997.

[C] Kim, Y. C. and Boudart, M., "Recombination of O, N, and H Atoms on Silica:Kinetics and Mechanism," Langmuir, Vol. 7, 1991.

[D] Marschall, J., "Experimental Determination of Oxygen and Nitrogen Recombination Coefficients at Elevated Temperature Using Laser-Induced Fluorescence," AIAA, Baltimore, MD, 1997.

Waiting for final results based on new DFT data specific to these reactions.



• Molecular beam experiments on Highly-Oriented Pyrolytic Graphite





Figure 3. Relative flux of scattered CO (top panel) and CO₂ (bottom panel) as a function of $\theta_{\rm f}$, with $\theta_{\rm i} = 45^{\circ}$. Red circles represent the flux of the thermal components and blue circles represent the flux of the hyperthermal components.

Exp: Prof. Minton – Montana State5th Ablation Workshop (2/29/12)20

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